

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	"20020032499".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 11:47
L2	34	"0061498"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 11:48
L3	2	"200061498"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 11:48
L4	2	"6569297".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 12:00
L5	2	wang.in. and leader.xa.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 15:00
L6	767	jacobian adj matrix	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:30
L7	768	jacobian adj (matrix matric)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:31
L8	66	jacobian adj (matrix matric) same sensitivity	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:31
L9	13	jacobian adj (matrix matric) same sensitivity and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:35
L10	80	error with sensitivity and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:35

L12	5	error with sensitivity with control\$4 and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:36
L13	353	error with control\$4 and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:36
L14	9	error with control\$4 with tolerance and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:37
L15	31	error with control\$4 with thickness and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:40
L17	237	contact adj finger and electroplating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:41
L18	172	contact adj finger and electroplating and (semiconductor microelectronic wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 13:41
L19	21	("5004399" "5046914" "5061144" "5168886" "5168887" "5180273" "5202716" "5224503" "5232511" "5235995" "5238500" "5301700" "5332445" "5339128" "5442416" "5445172" "5500081" "5544421" "5547515" "5566076" "5642298"). PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/06 13:56
L20	1	"5731678".pn.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/06 13:56
L21	1	"5731678".pn. and finger with current	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/06 14:30
L22	22	"6277263"	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/06 14:30
L23	1	"6277263".pn.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/06 14:34
L24	2	"9947731"	DERWENT	OR	ON	2005/10/06 14:35

L25	1	"6197181".pn.	DERWENT	OR	ON	2005/10/06 14:36
L26	1	"6290833".pn.	DERWENT	OR	ON	2005/10/06 14:36
L27	3398	semitool.as. coie	US-PGPUB; USPAT	OR	ON	2005/10/06 15:01
L28	77	27 and reactor adj head	US-PGPUB; USPAT	OR	ON	2005/10/06 15:01
L29	16	27 and reactor adj head.clm.	US-PGPUB; USPAT	OR	ON	2005/10/06 15:42
L30	1	"5597460".pn.	US-PGPUB; USPAT	OR	ON	2005/10/06 15:28
L31	1	"4304641".pn.	US-PGPUB; USPAT	OR	ON	2005/10/06 15:28
L32	14	27 and (principal adj fluid adj flow adj chamber).clm.	US-PGPUB; USPAT	OR	ON	2005/10/06 15:55
L33	5	27 and (principal adj fluid adj flow adj chamber).clm. and (control controller). clm.	US-PGPUB; USPAT	OR	ON	2005/10/06 15:55